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From: Pamela J. Squyres
Attorney Docket: MA-100-I
Phone: 408-869-2921

FAX NUMBER 571-273-8300

Re: Patent Application of: S. B. Herner	Examiner: Bret P. Chen
Serial No.: 10/769,047	Group Art Unit: 1762
Filed: January 30, 2004	Attorney Docket No.: MA-100-I
Title: Low Temperature, Low-Resistivity Heavily Doped P-Type Polysilicon Deposition	

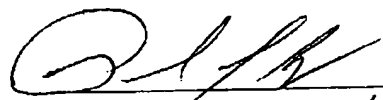
Document(s) Transmitted:

- ☐ Response to Non-Final Office Action (14 pages)
- ☐ Application Data Sheet (4 pages)

Total pages of this transmission, including the cover letter: 19

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Pamela J. Squyres
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